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**PATENT**  
5181-79300/P5790

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Application No.: 09/842,596

Filed: April 25, 2001

Inventors:

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Raghavendra Rao

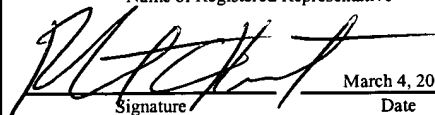
Title: Persistent Repository for  
On-Demand Node Creation  
for Fabric Devices

§ Examiner: Nano, Sargon N.  
§ Group/Art Unit: 2157  
§ Atty. Dkt. No: 5181-79300  
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I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date indicated below.

Robert C. Kowert

Name of Registered Representative



Signature

March 4, 2005

Date

**RESPONSE TO OFFICE ACTION OF  
DECEMBER 6, 2004**

**Mail Stop Amendment**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

This paper is submitted in response to the Office Action of December 6, 2004, to further highlight why the application is in condition for allowance.